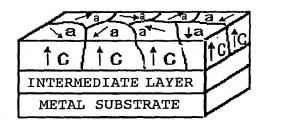
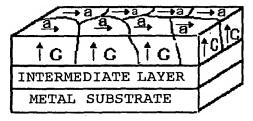
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FIG. 1A

FIG. 1B





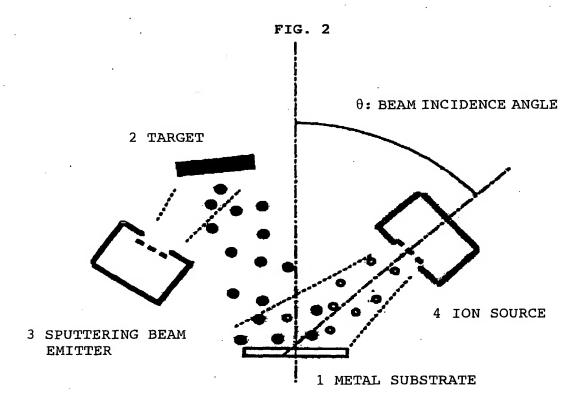


FIG. 3

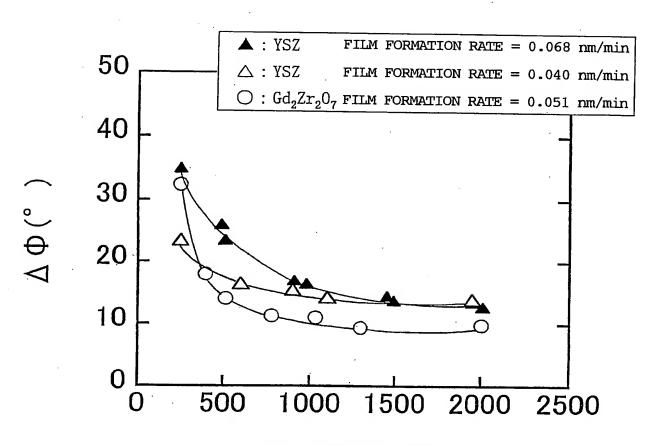
OXIDE SUPERCONDUCTING FILM CAP LAYER (CeO <sub>2</sub> LAYER)
IBAD INTERMEDIATE LAYER
METAL SUBSTRATE

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FIG. 4



IBAD THICKNESS (nm)

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FIG. 5A

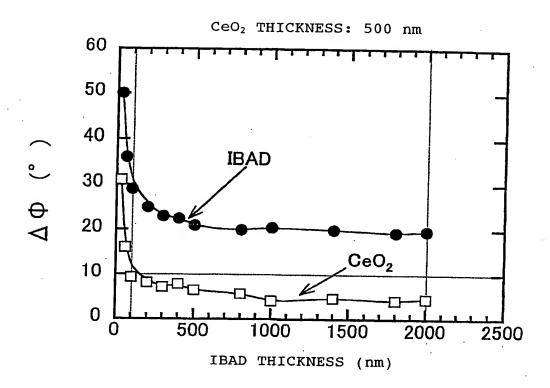
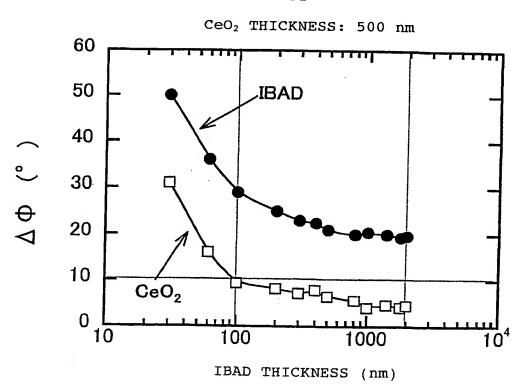
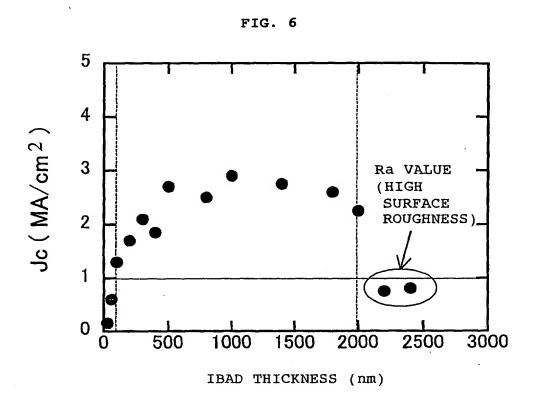
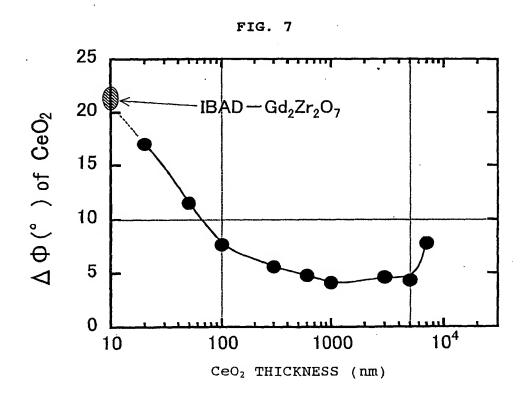


FIG. 5B



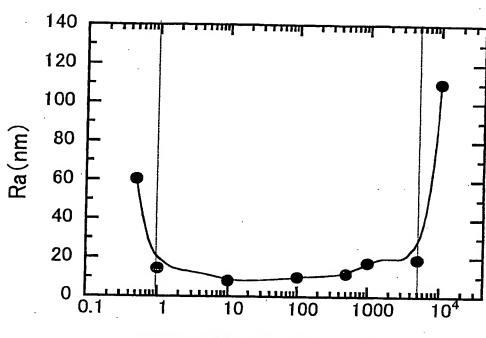




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FILM FORMATION RATE (nm/min)



